

Registration Number:

Date & Session

ST. JOSEPH'S COLLEGE (AUTONOMOUS), BENGALURU -27 B.Sc/B.A/B.Com– III SEMESTER SEMESTER EXAMINATION: NOVEMBER 2022 (Examination conducted in December 2022) PHOE 6 – INTRODUCTORY NANOTECHNOLOGY

Time: 2 Hours

Max Marks: 60

This paper contains <u>4</u> printed pages and <u>3</u> parts

PART-A

Answer the following

25×1=25

- 1. What is the average size of the red blood cells?
 - a) 4000nm
 - b) 3000nm
 - c) 6000nm
 - d) 7000nm
- 2. Which of the following is a 3D nanomaterial?
 - a) Nano wires
 - b) Nano tubes
 - c) Colloids
 - d) Thin films
- 3. Which of the following is NOT the quantum size effect?
 - a) Opaque substance becomes transparent
 - b) Stable material turns combustible aluminum
 - c) Insoluble material becomes soluble
 - d) None of the above
- 4. Which of the following best describes a Quantum Wells?
 - a) Confinement in two directions
 - b) Confinement in one direction
 - c) Confinement in all the three directions
 - d) No confinement
- 5. SEM stands for
 - a) Scanning Electron Microscope
 - b) Single Electron Microscope
 - c) Single Etalon Microscope
 - d) Surface Electron Microscope
- 6. The density of states of bulk system is determined by
 - a) E⁰
 - b) E^{-1/2}
 - c) E^{1/2}
 - d) E^{3/2}

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- 7. Quantum cryptography uses _____ to transmit data through fibre optic cable.
 - a) Photons
 - b) Phonons
 - c) Electrons
 - d) Positrons
- 8. Which of the following is not a bottom-up approach to nano material preparation?
 - a) Vapour phase deposition
 - b) Plasma assisted deposition
 - c) Molecular beam epitaxy
 - d) Lithographic techniques
- 9. Ultra-high vacuum range of pressure is _____.
 - a) 10⁻⁶ to 10⁻⁴
 - b) 10⁻⁵ to 10⁻¹⁰
 - c) 10⁻⁴ to 10⁻²
 - d) 10⁻¹² to 10⁻¹⁴
- 10. Which of the following is a growth monitoring method in Molecular beam epitaxy?
 - a) RHEED
 - b) IBM
 - c) LED
 - d) MOCVD
- 11. MEMS stands for
 - a) Nano Electro Mechanical Systems
 - b) Micro Electro Mechanical Systems
 - c) Micro Engineering Mechanical Systems
 - d) None of the above
- 12. Expand CVD
 - a) Controlled vapour deposition
 - b) Chemical Vapour deposition
 - c) Controlled voltage deposition
 - d) Chemical variation deposition
- 13. The removal or division of bulk material to get a desired nanostructures is known as
 - a) Top-down approach
 - b) Bottom-up approach
 - c) Sol-gel process
 - d) None of the above
- 14. _____ have two directions of growth and one direction of restriction.
 - a) Thin films
 - b) Thick films
 - c) Hard films
 - d) 2D layers



15. MBE uses a special source holder, which is known as _____

- a) Vacuum Chamber
- b) Knudsen cell
- c) Plasma cell
- d) None of the above
- 16. Which method is most suitable for QW fabrication?
 - a) Molecular beam Epitaxy
 - b) Micro beam Epitaxy
 - c) Molecular bunch Epitaxy
 - d) None of the above
- 17. The unit of hardness is the following:
 - a) Moh
 - b) Mho
 - c) Micron
 - d) Meter
- 18. The bound electron and hole pair is referred to as
 - a) Excitons
 - b) Electron pair
 - c) Hole pair
 - d) None of the above
- 19. Loosely bound excitons are referred to as
 - a) Exciton
 - b) Frenkel Exciton
 - c) Mott-Wannier Exciton
 - d) None of the above
- 20. The speed of light is
 - a) 3,00,000 Km/s
 - b) 330 m/s
 - c) 3000 m/s
 - d) 30 Km/s
- 21. Which of the following is the specialty of tunnel diodes?
 - a) Temperature sensitive
 - b) Doesn't require current
 - c) Doesn't require voltage
 - d) Resistant to nuclear radiation
- 22. GMR stands for
 - a) Giant Magneto Resistance
 - b) Giant Micro Resistance
 - c) Giant Micro Reactance
 - d) None of the above

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23. Which of the following is NOT a type of carbon nanotubes?

- a) Armchair
- b) ZigZag
- c) Helical
- d) Flowerily
- 24. The conductivity of ZigZag CNT is like
 - a) Insulator
 - b) Metal
 - c) Semiconductor
 - d) None of the above
- 25. The quantum Hall effect and its related constant was discovered by
 - a) Einstein
 - b) Newton
 - c) Klaus von Klitzing
 - d) Debye

PART-B

Answer any FIVE of the following

5×5=25

- 26. Discuss the formation of magnetic vortices with a neat diagram.
- 27. With a neat diagram, explain the formation of superlattices with minibands and minigaps.
- 28. Sketch the scattering and ballistic transport of electrons.
- 29. What do you mean by stark effect? Explain it with a neat diagram.
- 30. Discuss the top-down approach of nanomaterial fabrication.
- 31. Explain proximity printing lithography with a neat diagram.
- 32. Discuss the Oswald ripening process.
- 33. What do you mean by Nano indentation process? Discuss it.

PART-C

Answer the following

34. Write an essay on nanotechnology and its applications.

1×10=10